Ref	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1	("20040091607").PN.	US-PGPUB	OR	OFF	2005/02/15 08:16
L2	5	(("5736195") or ("5968268") or ("6059880") or ("6076979") or ("5776545")).PN.	US-PGPUB; USPAT	OR	OFF	2005/02/15 08:16
L3	10	("5776545").URPN.	USPAT	OR	OFF	2005/02/15 08:39
L4	1	"5460653".PN.	USPAT; USOCR	OR	OFF	2005/02/15 08:21
L5	1	"5455063".PN.	USPAT; USOCR	OR	OFF	2005/02/15 08:21
L6	1	"5348585".PN.	USPAT; USOCR	OR	OFF	2005/02/15 08:21
L7	1	"5116704".PN.	USPAT; USOCR	OR	OFF	2005/02/15 08:21
L8	1	"5037723".PN.	USPAT; USOCR	OR	OFF	2005/02/15 08:21
L9	2	jp-06151295-\$.did.	EPO; JPO; DERWENT	OR	OFF	2005/02/15 08:22
L10	2	jp-07321001-\$.did.	EPO; JPO; DERWENT	OR	OFF	2005/02/15 08:22
L11	3499	((427/8) or (427/420) or (427/421.1) or (427/424) or (427/427.2) or (427/427.3) or (427/427.4) or (427/427.6)).CCLS.	US-PGPUB; USPAT	OR	OFF	2005/02/15 08:39
L12	0	1 and ((photoresist or resist) same wafer)	US-PGPUB; USPAT	OR	ON	2005/02/15 08:40
L13	93	11 and ((photoresist or resist) same wafer)	US-PGPUB; USPAT	OR	ON	2005/02/15 08:45
L14	13595	((photoresist or resist) same wafer)	EPO; JPO; DERWENT	OR	ON	2005/02/15 08:45
L15	896	14 and edge	EPO; JPO; DERWENT	OR	ON	2005/02/15 08:45
L16	119	15 and nozzle	EPO; JPO; DERWENT	OR	ON	2005/02/15 08:49
L17	51	15 and flow	EPO; JPO; DERWENT	OR	ON	2005/02/15 08:49
L18	40	17 not 16	EPO; JPO; DERWENT	OR	ON	2005/02/15 08:50
L19	23	15 and movement	EPO; JPO; DERWENT	OR	ON	2005/02/15 08:51
L20	0	15 and rank	EPO; JPO; DERWENT	OR	ON	2005/02/15 08:51
L21	1	15 and file	EPO; JPO; DERWENT	OR	ON	2005/02/15 08:51

			· · · · · · · · · · · · · · · · · · ·			,
L22	124	15 and (step or stepped)	EPO; JPO; DERWENT	OR	ON	2005/02/15 08:51
L23	9	15 and (stepped)	EPO; JPO; DERWENT	OR	ON	2005/02/15 08:52
L24	3	15 and pitch	EPO; JPO; DERWENT	OR	ON	2005/02/15 08:52
L25	559	wafer and edge and nozzle	EPO; JPO; DERWENT	OR	ON	2005/02/15 08:53
L26	4	25 and (pitch or stepped)	EPO; JPO; DERWENT	OR	ON	2005/02/15 08:53
L27	122	25 and (move or moved or movement)	EPO; JPO; DERWENT	OR	ON	2005/02/15 08:58
L28	488	wafer same edge same nozzle same (move or moved or movement)	US-PGPUB; USPAT	OR	ON	2005/02/15 09:10
L29	437	28 and (flow or flowed or flowing)	US-PGPUB; USPAT	OR	ON	2005/02/15 08:59
L30	206	28 same (flow or flowed or flowing)	US-PGPUB; USPAT	OR	ON	2005/02/15 09:02
L31	231	29 not 30	US-PGPUB; USPAT	OR	ON	2005/02/15 09:02
L32	. 1	"6190063".PN.	USPAT; USOCR	OR	OFF	2005/02/15 09:08
L33	1	"6117486".PN.	USPAT; USOCR	OR	OFF	2005/02/15 09:08
L34	1	"6063439".PN.	USPAT; USOCR	OR	OFF	2005/02/15 09:09
L35	1	"6004047".PN.	USPAT; USOCR	OR	OFF	2005/02/15 09:09
L36	2	("6383948").URPN.	USPAT	OR	OFF	2005/02/15 09:10
L37	707	wafer same edge same line same (move or moved or movement)	US-PGPUB; USPAT	OR	ON	2005/02/15 09:11
L38	295	wafer same nozzle same line same (move or moved or movement)	US-PGPUB; USPAT	OR	ON	2005/02/15 09:13
L39	63	38 same (x or y)	US-PGPUB; USPAT	OR	ON	2005/02/15 09:11
L40	194	wafer same nozzle same scanning	US-PGPUB; USPAT	OR	ON	2005/02/15 09:13
L41	45	40 same (x or y)	US-PGPUB; USPAT	OR	ON	2005/02/15 09:13